



IFW

WEGMAN, HESSLER & VANDERBURG

A LEGAL PROFESSIONAL ASSOCIATION
ATTORNEYS AT LAW

DAVID J. HESSLER
KEITH A. VANDERBURG
PETER A. HESSLER
DAVID R. KNOWLES
JOHN D. KEDZIOR
STEVEN E. PRYATEL
RICHARD T. COYNE
LAWRENCE S. CROWTHER
CHRISTOPHER A. HOLECEK
JEFFREY W. KRUEGER
BRUCE E. PEACOCK **
DAVID W. HERRINGTON
ANTOINETTE F. GIDEON
TANJA M. HOLECEK
DAVID R. BUTTON

KARL R. WETZEL
NATHAN E. HESSLER
DONNA M. DRESS

SUITE 200
6055 ROCKSIDE WOODS BOULEVARD
CLEVELAND, OHIO 44131-2302
WWW.WEGMANLAW.COM

TELEPHONE
(216) 642-3342

FACSIMILE
(216) 642-8826

April 21, 2006

SIMON P. DEMIAN
JENNIFER A. CORSO
CHRISTOPHER W. KRAUSE
LESLEY A. WEIGAND
ANGELA M. LAVIN
ANDREW C. LAKE **
DANIELLE A. SKOCZEN **
CHRISTOPHER A. CORPUS
MATTHEW G. BURG
JEFFREY S. ELLSWORTH **
DAVID H. BROWN

CHARLES R. ENNIS
OF COUNSEL

MARTIN J. WEGMAN
(1918-1977)

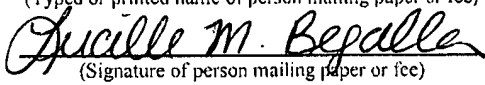
* California and Missouri only

** Registered Patent Attorney

In re Application of

Inventor : Alexander Leybovich
Serial No. : 10/624,384
Filed : July 22, 2003
Title : **Method and Apparatus for Deposition
Of Low-K Dielectric Materials**
Examiner : Steven H. VerSteeg
Art Unit : 1753
Docket : 020324 227P2
Customer No. 33805

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450


| |
|---|
| <p align="center">CERTIFICATE OF MAILING</p> <p>I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Mail Stop Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.</p> <p align="center"><u>April 21, 2006</u> (Date of Deposit)</p> <p align="center"><u>Lucille M. Begalla</u> (Typed or printed name of person mailing paper or fee)</p> <p align="center"> (Signature of person mailing paper or fee)</p> |
|---|

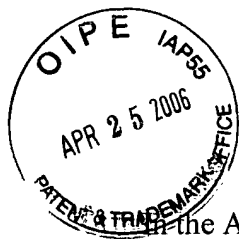
Transmitted herewith are the following in the above-identified application.

XX Amendment

XX A check in the amount of \$0.00. The Commissioner is hereby authorized to charge any additional fees under 37 C.F.R. 1.16 and 1.17 which may be required by this paper, or to credit any overpayment, to Deposit Account No. 502431. Two copies of this sheet are enclosed.

Respectfully submitted,
WEGMAN, HESSLER & VANDERBURG

By: 
Jeffrey S. Ellsworth
Reg. No. 51,450



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In the Application of:

Inventors : Alexander Leybovich
Serial No. : 10/624,384
Filed : July 22, 2003
Title : METHOD AND APPARATUS FOR DEPOSITION
OF LOW-K DIELECTRIC MATERIALS
Examiner : Steven H. Versteeg
Art Unit : 1753
Docket No. : 020324 227P2
Customer No.: 33,805

Mail Stop Amendment

Commissioner for Patents

P.O. Box 1450

Alexandria, Virginia 22313-1450

Sir:

AMENDMENT UNDER 37 C.F.R. 1.111

In response to the Office Action mailed January 23, 2006, please amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 6 of this paper.

DEPOSIT ACCOUNT USE AUTHORIZATION

Please charge any fee necessary or due to assure entry to:

USPTO Deposit Account No. 502431

Wegman, Hessler & Vanderburg
6055 Rockside Woods Boulevard
Cleveland, Ohio 44131
Telephone: (216) 642-3342
USPTO Customer No. 33805